# **Special Issue**

## High-Performance MEMS Sensors

## Message from the Guest Editor

The importance of MEMS technology is continuously increasing as they become more widespread in a broad variety of applications ranging from low-power devices for IoT and battery-powered applications to high-end devices for precise navigation and positioning. Industry 4.0. enhanced virtual reality components and smartphones. MEMS technology is receiving substantial industrial attention. The concept of integrating sensors, actuators, electrical (and electronic) and mechanical devices into a single chip is considered as a basis for breakthrough technologies. The aim of the Special Issue is to introduce the state-of-the-art technologies in the field of sensors, mechatronics, MEMS devices and microsystems in order to further summarize and improve on the methodologies concerning microsystems and MEMS devices. For more information, please click: mdpi.com/si/121677

### **Guest Editor**

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### Deadline for manuscript submissions

closed (30 March 2023)



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### Message from the Editor-in-Chief

Sensors is a leading journal devoted to fast publication of the latest achievements of technological developments and scientific research in the huge area of physical, chemical and biochemical sensors, including remote sensing and sensor networks. Both experimental and theoretical papers are published, including all aspects of sensor design, technology, proof of concept and application. Sensors organizes Special Issues devoted to specific sensing areas and applications each year.

#### Editor-in-Chief

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